

MDPI

Editorial

Acknowledgment to the Reviewers of Automation in 2022

Automation Editorial Office

MDPI AG, St. Alban-Anlage 66, 4052 Basel, Switzerland

High-quality academic publishing is built on rigorous peer review. *Automation* was able to uphold its high standards for published papers due to the outstanding efforts of our reviewers. Thanks to the efforts of our reviewers in 2022, the median time to first decision was 19 days and the median time to publication was 48 days. Regardless of whether the articles they examined were ultimately published, the editors would like to express their appreciation and thank the following reviewers for the time and dedication that they have shown *Automation*:

Abbasi, Mahmoud Ahmed-Ali, Tarek Akram, Nadia Akuru, Udochukwu B.

Angelidis, Georgios Araszkiewicz, Andrzej

Bai, Xiaoshan Bajno, Dariusz

Balasubramanian, Esakki

Balicki, Jerzy Bhowmik, Palash Caldeira, Eliete Calegari, Roberta Calvetti, Diego Chang, Yao-Feng Chirkova, Julia Chung, Kyungyong

Cotas, Carla Czumbil, Levente Danczyk, Stephen Demidova, Liliya A. Eduardo Espitia, Helbert Fivos, Papadimitriou

Fuhr, Norbert Ghaemi, Hossein Girovský, Peter Gorbenko, Anna

Hadjiefthymiades, Stathes

Havig, Paul

Herschfelt, Andrew Hu, Fuwen Huang, Yanwei Jagtap, Ameya Katunský, Dušan Kodkin, Vladimir Kurita, Koichi Li, Shuo Li, Tongyun

Mahmoud, Samy R. Mao, Yachun

Martínez-Jiménez, Eva María

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Oliveira, Andre Schneider De O'Shea-Wheller, Thomas A. Oyarbide-Zubillaga, Aitor

Park, Herie Postolache, Mihai Qiu, Qiwen Ritschel, Uwe

Ruiz Armenteros, Antonio Miguel

Rzonca, Dariusz Saito, Yuichi

Santos, Max Mauro Dias

Sarir, Payam Severin, Irina Song, Tianqi Sun, Zhaowei Sutcliffe, Mark Tan, Wen

Vazquez-Becerra, Guadalupe Esteban

Verbree, Edward Villanueva, Juan Wang, Hongbo Wang, Hongwu Wang, Junfeng Wang, Xinwei

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Wen, Chih-Yu Wysocki, Marian Yeh, Yi-Liang Zawarczyński, Łukasz Zhang, Bin

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